

Docket Number  
42697.124 USApplication Number  
09/807,838INFORMATION DISCLOSURE  
IN AN APPLICATION

(Use several sheets if necessary)

Applicant

Gordon et al.

Filing Date

July 16, 2001

Group Art Unit

1621

## U.S. Patent Documents

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
SB	5,139,999	8/1992	Gordon et al.	—	—	
KMS	4,501,602	2/1985	Miller et al.	—	—	
CWI	5,248,787	9/1993	Timmer et al.	—	—	
RK	5,280,012	1/1994	Kirlin et al.	—	—	
CWI	5,225,561	7/1993	Kirlin et al.	—	—	
HK	5,518,536	5/1996	Doellein	—	—	

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## Foreign Patent Documents

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

## Other Documents (Including Author, Title, Date Pertinent Pages, Etc.)

C1.	Wojtczak et al. "A Review of Group 2 (Ca, Sr, Ba) Metal-Organic Compounds as Precursors for Chemical Vapor Deposition," 40 <i>Advances in Organometallic Chemistry</i> 215-340 (1996)
C2.	Gordon et al. "New Liquid Precursors for Chemical Vapor Deposition," 495 <i>Materials Research Society Symposium</i> 63-68 (1998)
C3.	Buriak et al. "The Use of Amines to Enhance the Volatility of Barium Beta-Diketonates: Chemical Vapor Deposition of Barium Oxide Thin Films," 29 <i>Eur. J. Solid State Inorg. Chem.</i> Abstract 43-50 (1992)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP § 609: Draw Line through citation if not conformance and not considered. Include copy with next communication to applicant.